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PATENT 90065.99R272 (17732.6323) Response Under 37 CFR 1.111

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant:

Jifa Hao, et al.

Serial No.:

09/654,845

Examiner: Ori Nadav

Art Unit: 2811

Filed:

September 01, 2000

Title:

POWER SEMICONDUCTOR

DEVICE WITH HIGH

AVALANCHE CAPABILITY AND

PROCESS FOR FORMING

SAME

RESPONSE UNDER 37 CFR 1.116

MS: Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 11, 2005, Applicants hereby submit the following Amendment and Remarks.

ereby